EAST

	L#	Hits	Search Text	DBs	Time Stamp	Туре
1	L1	89125	(IC OR integrated ADJ circuit) WITH (design\$3 OR order\$3 OR custom\$)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/16 19:00	BRS
2	L2	25558	L1 SAME (factory OR production OR assembly OR manufactur\$3 OR fabricat\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/16 19:01	BRS
3	L4	743	L2 SAME (www OR "world wide web" OR internet OR intranet OR network)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/16 19:02	BRS
4	L5	257	L4 AND (db OR database OR "data base")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/16 19:37	BRS
5	L6	56	L4 SAME (db OR database OR "data base")	HPC). IPC). LIEDWING.	2005/03/16 19:03	BRS
6	L7	76	L5 AND (CAD OR CAM OR CAE OR computer ADJ aided ADJ (design\$3 OR draft\$3 OR draw\$3 OR manufactur\$3 OR machin\$3 OR engineer\$))		2005/03/16 19:38	BRS
7	L8	64	L7 NOT L6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/16 19:39	BRS
8	L9	12	L7 AND L6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/16 19:39	BRS

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UO)ged (13) C 242					PS tom A 158				.J 		STEPPE TOT	
¥.	Decument # US 6725237 B2	Source USPAT	Issue Date 20040420	Titte System and method of preparing data for a semiconductor mask manufacturer	Current 707/104 1	Inventor Clairment, James B. et al.	П	.	n		image Coc 1 US 6725237	<u>Р</u> Г	
Ç	US 6668360 B1	USPAT	20031223	Automatic integrated circuit design kit qualification service provided through the internet	716/4	Liu; Louis	5	r	٦	Г	US 6668360	г	
Þ	US 6622295 B1	USPAT	20030916	Network-based photomask data entry interface and instruction generator for manufacturing photomasks	716/19	Schepp; Jeffry S. et al.	Y	Г	r	r	US 6622295	С	
Ş	US 6594799 B1	USPAT	20030715	Method and system for facilitating electronic circuit and chip design using remotely located resources	716/1	Robertson; William H. et al	1	E.	Г	Γ.	US 6594799	E.	
P	US 20040117374 A1	US-PG PUB	20040617	Customized design portfolio integrating IP libraries and technology documents	707/10	Hung, Lup Cheong Patrick et al.	1	Б	r		US 20040117374	С	
P	US 20040107214 A1		20040603	Customized document portfolio system integrating IP libraries and technology documents		Hung, Lup Cheong Patrick et al.	1	r	Γ		US 20040107214	Г	
Ş	US 20040098391 A1		20040520	Method and system for facilitating electronic circuit and chip design using remotely located resources	707/10	Robertson, William H. et al.	}	С	r		US 20040098391	Б	
Ŋ.	US 20040054982 A1		20040318	Network-based photomask data entry interface and instruction generator for manufacturing photomasks	716/21	Schepp, Jeffry S. et al.	R	Г	n		US 20040054982		
D	US 20030126153 A1	US-PG PUB	20030703	System and method of preparing data for a semiconductor mask manufacturer	707/104. 1	Clairmont, James B. et al.	С	Г	r	-	US 20030126153	n n	
Þ	US 20020188910 A1		20021212	Method and system for chip design using remotely located resources	718/1	Zizzo, Claudio	r	r	r	and the state of t	US 20020188910	п	
n	US 20020081501 A1	US-PG PUB	20020627	Device manufacturing method, photomask used for the method, and photomask manufacturing method		Hasegawa, Norio et al.	P	Г	n	:	US 20020081501	П	
₽.	US 20020016948 A1		20 020207	Method and configuration for verifying a layout of an integrated circuit and application thereof for fabricating the integrated	716/1	Rein, Achim et al	₽.	T.	C		US 20020016948	 	
Ø	US 20010044667 A1		20011122	circuit. System of manufacturing semiconductor intergrated circuit	700/100	Hirotaka et al.	₽	េ	r l	-	US 20010044667	п.	

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L#	its Search Text	DBs	Time Stamp	Туре
1 L10	("5201071" "5728598" "4872011" "4905006" "5847609" "4323731" "4472831" "4479233" "4494137" "4535470" "4536885" "4541109" "4589127" "4757539" "5027186" "5253298" "5289502" "5629570" "5731740" "6107700" "6256482" "6362668" "6421278" "6476632" "4554873" "4785453" "5453978" "5466619" "5583764" "5606703" "5689414" "5721957" "5838589" "5926583" "6038350" "6249913" "6314442" "6343323" "6532163" "6574652" "4426728" RE33381 "3676791" "4079204" "4105868" "4248986" "4259446" "4373115" "4769842" "4850020").pn.	USPAT	2005/03/16 19:42	BRS

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Most Frequently Occurring Classifications of Patents Returned From A Search of 10675690 on March 15, 2005

Original Classifications 8 381/15

- 7 381/16
- 2 341/150
- 2 382/304

Cross-Reference Classifications

- 2 327/46
- 2 332/145
- 2 332/159
- 2 348/721
- 2 358/443
- 2 358/447
- 2 381/15
- 2 455/102
- 2 455/205
- 2 700/4

Combined Classifications 10 381/15

- 8 381/16
- 2 327/46
- 2 332/145
- 2 332/159 2 341/150
- 2 348/721
- 2 358/443
- 2 358/447
- 2 382/304 2 455/102
- 2 455/205
- 2 700/286
- 2 700/4
- 2 702/2